

Serial No. 09/745,350

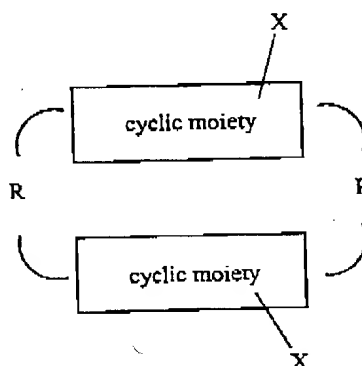
Docket No. 27710-A

Claims:

Please amend the claims as follows:

1. (Currently Amended) A method of forming a precursor for use in manufacturing integrated circuits comprising the steps of:

providing a quantity of an antireflective compound and a substrate having a surface onto which said compound is to be applied, said antireflective compound having the formula



wherein:

each R is individually selected from the group consisting of alkyl groups represents a linkage group; and

each X is individually selected from the group consisting of hydrogen, the halogens, nitro groups, amino groups, acetamido groups, substituted and unsubstituted cyclic and heterocyclic groups, and COR<sup>1</sup>, where R<sup>1</sup> is selected from the group consisting of hydrogen, substituted and unsubstituted phenyl groups,